

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.  
Applicant  
Filed  
Title



10/722,758  
Masaki Tamaru et al.  
November 26, 2003  
SEMICONDUCTOR DEVICE AND METHOD OF  
MANUFACTURING THE SAME UTILIZING PERMITTIVITY  
OF AN INSULATING LAYER TO PROVIDE A DESIRED  
CROSS CONDUCTIVE LAYER CAPACITANCE PROPERTY

Conf. No. : 7196  
TC/A.U. : 2811  
Examiner : Hung K. Vu

Customer No. : 000,116  
Docket No. : 32811US1

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

In accordance with 37 C.F.R. 1.97 and 1.98, Applicant is submitting herewith Form PTO-1449 listing references for consideration by the Examiner. Also submitted herewith is a legible copy of each reference, as well as a copy of a Japanese Office Action (English language translation attached).

Enclosed is a check in the amount of \$180.00 under 37 CFR 1.117(p). If there are any additional fees associated with this communication, please charge said fees to Deposit Account No. 16-0820, Order No. 32811US1.

Respectfully submitted,

PEARNE & GORDON LLP

03/03/2005 HGUTEMA1 00000044 10722758

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180.00 DP

By:

  
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Date: February 28, 2005


I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Mail Stop Amendment, P.O. Box 1450, Alexandria, VA 22313-1450 on the date indicated below.

Michael W. Garvey

Name of Attorney for Applicant(s)

February 28, 2005

Date

  
Signature of Attorney

Form PTO-1449	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE	ATTY. DOCKET NO. <b>32811US1</b>	SERIAL NO. <b>10/722,758</b>
<b>INFORMATION DISCLOSURE CITATION BY APPLICANT</b> <i>(USE SEVERAL SHEETS IF NECESSARY)</i>		APPLICANT: <b>Masaki Tamaru et al.</b>	
		FILING DATE: <b>November 26, 2003</b>	GROUP ART UNIT: <b>2811</b>

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**U.S. PATENT DOCUMENTS**

Examiner Initial	Document No.	Date	Name	Class	Subclass	Filing Date
	A					
	B					
	C					
	D					
	E					
	F					
	G					
	H					
	I					
	J					

**FOREIGN PATENT DOCUMENTS**

Document No.	Date	Country	Class	Subclass	Translation
K 7-161932	6/1995	JP			No/Cited in JP Office action
L 10-65101	3/1998	JP			No/Cited in JP Office action
M 2-33966	2/1990	JP			No/Cited in JP Office action
N 61-226949	10/1986	JP			No/Cited in JP Office action
O 3-293775	12/1991	JP			No/Cited in JP Office action
P					

**OTHER REFERENCES** *(Including Author, Title, Date, Pertinent Pages, Etc.)*

Q	
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Examiner:	Date Considered
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\*Examiner: Initial if reference considered, regardless of whether citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.